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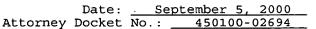
Patent Application Transmittal

(only for new nonprovisional applications under 37 C.F.R. 1.53(b)) Correspondence Address:

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ASSISTANT COMMISSIONER FOR PATENTS Box Patent Application Washington, D.C. 20231

Sir:

With reference to the filing in the United States Patent and Trademark Office of an application for patent in the name(s) of:

Hajime YANO, Hiroaki OISHI, Toyomi FUJINO

entitled:

RECORDING/REPRODUCTION APPARATUS AND RECORDING/REPRODUCTION METHOD

The following are enclosed: X Specification (55 pages) 8 Sheet(s) of Drawings Claim(s) (including independent claim(s)) 16 2 This application contains a multiple dependent claim  $\underline{X}$  Our check for  $\underline{$690.00}$ , calculated on the basis of the claims as amended by any enclosed preliminary amendment as follows:

Basic Fee, \$690.00 (\$345.00) Number of Claims in excess of 20 at \$18.00 (\$9.00) each: . . . . -0-Number of Independent Claims in excess of 3 at \$78.00 (\$39.00) each: Multiple Dependent Claim Fee at \$260.00 (\$130.00) . . . . . . Total Filing Fee 

\_ Assignment Recording Fee \$40.00 . . . . . . . . . . . . .

X Oath or Declaration and Power of Attorney X New \_\_\_ signed X unsigned \_\_\_ Copy from a prior application (37 C.F.R. 1.63(d))

X Certified copy of each of the following application(s) to substantiate the claim(s) for priority made in the Declaration:

> Application No. <u>Filed</u> 6 September 1999 11-252326 Japan 2000-134307 28 April 2000 Japan

Please charge any additional fees required for the filing of this application or credit any overpayment to Deposit Account No. 50-0320.

Respectfully submitted,

FROMMER LAWRENCE & HAUG LLP Attorneys for Applicants

William S. Frommer

Reg. No. 25,506

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September 5, 2000

Assistant Commissioner for Patents

Washington, D.C. 20231

Re: U.S. Patent Application

Applicants: Hajime YANO, Hiroaki OISHI, Toyomi FUJINO

Our Ref.: 450100-02694

Dear Sir:

Enclosed are papers constituting the above patent application which is being filed under 37 C.F.R. 1.53 without a signed Declaration. Please accord a filing date and a serial number to such application and inform the undersigned thereof so that a signed Declaration and the surcharge required by 37 C.F.R. 1.16(e) may be duly filed.

Please address all correspondence to:

William S. Frommer, Esq. FROMMER LAWRENCE & HAUG LLP 745 Fifth Avenue New York, New York 10151

Respectfully,

William S. Frommer Reg. No. 25,506

Attorney for Applicants

**Enclosures**